

REMARKS

Applicants will address each of the Examiner's objections and rejections in the order in which they appear in the Office Action.

Specification

In the Office Action, the Examiner objects to the title as not descriptive and is requiring that a new title be submitted. Accordingly, Applicants have amended the title to recite "Display Device", which is consistent with the claims. Therefore, it is respectfully requested that this objection be withdrawn.

Claim Rejections - 35 USC §102

The Examiner also rejects Claim 42 under 35 USC §102(e) as being anticipated by Miyawaki et al. (US 6,157,429). This rejection is respectfully traversed.

More specifically, in the Office Action, the Examiner contends that Miyawaki discloses the claimed invention in Fig. 3 and has "an EL element 14 formed on the interlayer insulating film 9."

However, Miyawaki clearly states that 14 is "a liquid crystal material." See col. 13, ln. 36. Since Claim 42 requires an EL element and not a liquid crystal material, Miyawaki does not disclose or suggest the display device of independent Claim 42 of the present application.

Therefore, for at least the above-stated reason, Claim 42 is patentable over Miyawaki. Accordingly, it is respectfully requested that this rejection be withdrawn.

Claim Rejections - 35 USC §103

The Examiner also rejects Claims 18-41 and 43 under 35 USC §103(a) as being unpatentable over Miyawaki in view of Alluri et al. (US 6,583,057). This rejection is also respectfully traversed.

While Applicants respectfully traverse this rejection, in order to advance the prosecution of this application, Applicants have amended independent Claims 18, 24, 30 and 36 to recite “a field effect transistor comprising a semiconductor layer formed on an upper surface of the insulating layer, and a gate electrode adjacent to the semiconductor layer with a gate insulating film interposed therebetween” (emphasis added). This is shown, for example, in Fig. 4 of the present application. See also e.g. pages 19-20 of the present application.

In contrast, the Examiner cites to Fig. 3 in Miyawaki as allegedly disclosing the device of independent Claims 18, 24, 30 and 36, with an insulating layer 6. However, Fig. 3 in Miyawaki does not disclose a semiconductor layer (e.g. 3, 5) formed on the upper surface of insulating layer 6 (neither does Alluri), as in the claimed invention. Instead, an insulating layer 8' is located on the upper surface of field oxide film 6. Hence, the cited references fail to disclose or suggest the device of independent Claims 18, 24, 30 and 36 and those claims dependent thereon. Therefore, these claims are patentable over the cited references, and it is respectfully requested that this rejection be withdrawn.¹

Conclusion

It is respectfully submitted that the present application is in a condition for allowance and should be allowed.

¹ Claim 43 depends on independent Claim 42 and is patentable for at least the reasons discussed

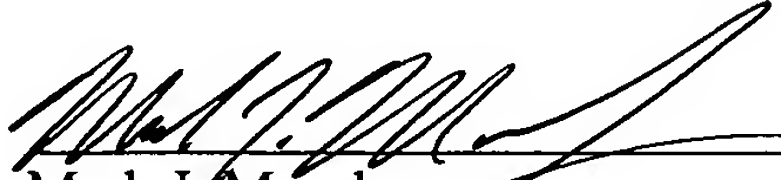
If any fee is due for this amendment, please charge our deposition account 50/1039.

Favorable reconsideration is earnestly solicited.

Respectfully submitted,

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above for independent Claim 42.